

M Meetings Calendar

The following list is a selection of meetings sponsored exclusively by or organized in association with the Japan Society of Applied Physics.

1999

25-26 November Sendai, Japan

3rd ICRS International Symposium

Hiroshi Kosugi, Institute for Chemical Reaction Science, Tohoku University,

Katahira 2-1-1, Aoba-ku, Sendai 980-8577, Japan;

Phone +81-22-217-5602

Fax +81-22-217-5603

Email hkosugi@icrs.tohoku.ac.jp

Website <http://icrs.tohoku.ac.jp>

9-11 December Izu, Japan

The 7th International Colloquium on Scanning Probe Microscopy

Hidemi Shigekawa, Program Chair, Institute of Applied Physics, University of Tsukuba,

Tsukuba 305-8573, Japan

Phone/Fax +81-298-53-5276

Email hidemi@ims.tsukuba.ac.jp

2000

8-11 January Furano, Japan

Symposium on Surface Physics'2000 (SSP'2000)

T.Koshikawa, Osaka Electro-Communication University, 18-8 Hatsu-cho, Neyagawa, Osaka 572-8530, Japan;

Phone +81-720-24-1131(ext 2582),

Fax +81-720-25-4590,

Email kosikawa@isc.osakac.ac.jp

28-30 January Sasebo, Japan

Basic Aspects of Non-equilibrium Plasmas Interacting with Surfaces (BANPIS-2000)

K.Tachibana, Graduate School of Engineering Department of Science and Engineering, Kyoto University, Yoshidahon-cho, Sakyo-ku, Kyoto-city, Kyoto 606-8501, Japan;

Phone +81-75-753-5304

Fax +81-75-753-3341

Email tatibana@kuee.kyoto-u.ac.jp

28-31 March Tokyo, Japan

2000 Spring Mtg. of Japan Society of Applied Physics

The Japan Society of Applied Physics,

1-12-3 Kudan-kita, Chiyoda-ku, Tokyo 102-0073, Japan;

Phone +81-3-3238-1041

Fax +81-3-3221-6245

Email technical-meetings@jsap.or.jp

Website <http://www.jsap.or.jp>

5-9 June Sapporo, Japan

The Tenth International Conference on Metal Organic Vapor Phase Epitaxy (ICMOVPE-X)

Takashi Fukui, Hokkaido University,

Email fukui@rciqe.hokudai.ac.jp,

Website <http://www2u.biglobe.ne.jp/~icmovpe/>

12-15 June Honolulu, USA

2000 Symposium on VLSI Technology

Secretariat for VLSI Symposia, c/o Business Center for Academic Societies Japan,

5-16-9 Honkomagome, Bunkyo-ku, Tokyo 113-8622, Japan;

Phone +81-3-5814-5800

Fax +81-3-5814-5823

Email vlsisym@bcasj.or.jp

Website http://www.bcasj.or.jp/vlsi_sym/

14-17 June Honolulu, USA

2000 Symposium on VLSI Circuits

Secretariat for VLSI Symposia, c/o Business Center for Academic Societies Japan,

5-16-9 Honkomagome, Bunkyo-ku, Tokyo 113-8622, Japan;

Phone +81-3-5814-5800

Fax +81-3-5814-5823

Email vlsisym@bcasj.or.jp

Website http://www.bcasj.or.jp/vlsi_sym/

25-30 June Nagaoka, Japan

13th International Conference on High-Power Particle Beams (BEAMS 2000)

K. Yatsui, Nagaoka University of Technology, Nagaoka, Niigata 940-2188, Japan

Phone +81-258-47-9891

Fax +81-258-47-9890

Email yatsui@nagaokaut.ac.jp

Website <http://etigo.nagaokaut.ac.jp/beams>

3-7 September Sapporo, Japan

2000 Autumn Mtg. of Japan Society of Applied Physics

The Japan Society of Applied Physics,

1-12-3 Kudan-kita, Chiyoda-ku, Tokyo 102-0073, Japan;

Phone +81-3-3238-1041

Fax +81-3-3221-6245

Email technical-meetings@jsap.or.jp

Website <http://www.jsap.or.jp>

M Meetings Calendar

18-22 September *Osaka, Japan*

25th International Conference on the Physics of Semiconductors ICPS 2000

C. Hamaguchi, Department of Electronic Engineering, Osaka University,

Suita City, Osaka 565-0871, Japan;

Phone +81-6-879-7765

Fax +81-6-879-7753

Email hamaguti@ele.eng.osaka-u.ac.jp

24-27 September *Nagoya, Japan*

International Workshop on Nitride Semiconductors (IWN2000)

Katsumi Kishino, Department of Electrical and Electronics Engineering, Sophia University,

Kioi-cho, Chiyoda-ku, Tokyo 102-8554, Japan;

Phone +81-3-3238-3325

Fax +81-3-3238-3321

Email iwn2000@katsumi.ee.sophia.ac.jp

Website <http://www.etl.go.jp/~iwn2000/Home.html>

2001

7-13 January *Furano, Japan*

Symposium on Surface Science (3S'01)

A. Ichimiya, Chair 3S'01, Department of Quantum Engineering, Nagoya University,

Nagoya 464-8603, Japan;

Phone +81-52-789-4459

Fax +81-52-789-3703

Email ichimiya@nuqe.nagoya-u.ac.jp

15- 20 July *Nagoya, Japan*

XXVth International Conference on Phenomena in Ionized Gases

Nagoya Congress Center,

Toshio Goto, Department of Quantum Engineering, Nagoya University,

Nagoya 464-8603, Japan,

Phone +81-52-789-3314

Fax +81-52-789-3164

Email gotou@nuqe.nagoya-u.ac.jp

30 July-4 August *Kyoto, Japan*

The Thirteenth International Conference on Crystal Growth (ICCG-13) in conjunction with The Eleventh International Conference on Vapor Growth and Epitaxy (ICVGE-11)

T. Ohachi, Department of Electrical Engineering, Doshisha University,

Kyotanabe-city, Kyoto 610-0321, Japan;

Phone +81-774-65-6329

Fax +81-774-65-6811

Email tohachi@mail.doshisha.ac.jp

Website <http://iccg.doshisha.ac.jp/>

